

Application/Control No.	Applicant(s)/Patent under Reexamination
10/672,073	WEDEL ET AL.
Examiner	Art Unit
Michael J. Hicks	2165

SEARCHED					
Class	Subclass	Date	Examiner		
707	101	7/27/2006	1/2/		
707	102	7/27/2006			
707	10	7/27/2006			
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INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
707	101	7/27/2006	NAH		
707	102	7/27/2006			
707	10	7/27/2006			

SEARCH NOTES (INCLUDING SEARCH STRATEGY)				
	DATE	EXMR		
Inventor Name Search	7/27/2006	M		
Assignee Search	7/27/2006			
Review of Previously Identified Prior Art	7/27/2006			
Updated Patent Database Search - East	7/27/2006			
Updated NPL Search - ACM - Google - Google Scholar	7/27/2006			
Consulted with Examiner Apu Mofiz	7/27/2006			